

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s):	Reddy Vangala	)	Examiner: Benny T. Lee
Application No.:	10/550,523	)	Confirmation No.: 4425
Filed:	September 22, 2005	)	Group Art Unit: 2817
For:	Low Profile Ceramic RF Filter	)	Attorney Docket No.: WC0157

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Mail Stop PCT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicants hereby submit a completed form PTO/SB/08A listing documents that may be material to the examination of this application. The Examiner is requested to review these documents and to determine the extent of the materiality of the document disclosures, if any, with respect to the present invention.

Specifically, and pursuant to the requirements of 37 C.F.R. § 1.97 (b)(3), this supplemental information disclosure statement is being filed before the mailing of a first Office Action on the merits. The document contained in this supplemental information disclosure statement was first cited in a European Patent Office official communication dated October 23, 2006.


No inference should be drawn that the attached list represents a comprehensive investigation or that any disclosures in the listed documents are equivalent to the subject invention. The discussion of any art and the citation of any documents herein is not to be construed as an admission that they are necessarily within the invention field of endeavor or prior in time to a particular date which may be relevant with respect to the instant application. Further, the recitation herein of the art and documents is not to be construed as an assertion that more pertinent art could not possibly be in existence or that the newly cited documents are necessarily prior art as defined by the patent law.

Applicants reserve the right to later set forth how the claimed invention is distinguished over the disclosure of any document or other art, including the disclosures of the art and documents cited herein, and that may be cited by the Examiner in rejecting a claim in the instant patent application.

This authority is hereby authorized to charge any deficiency or credit any overpayment in connection with this filing to Deposit Account No. 03-1677.

Respectfully submitted,

Date: March 15, 2007

  
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#### CERTIFICATE OF MAILING

I, Joan C. Ramm, hereby certify that this Supplemental Information Disclosure Statement is being deposited with the United States Postal Service as First Class Mail, postage pre-paid, on March 15, 2007 in an envelope addressed to: Mail Stop PCT, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

  
Joan C. Ramm

U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

Comparable to Form PTO/SB/08A

# INFORMATION DISCLOSURE STATEMENT BY APPLICANT

**Complete if Known**

Application Number:	10/550,523
Filing Date:	September 22, 2005
First Named Inventor:	Reddy Vangala
Art Unit:	2817
Examiner Name:	Benny T. Lee
Atty. Docket No.:	WC0157

**U.S. PATENT DOCUMENTS**

Examiner Initials	Cite No.	Document Number Number-Kind Code (if known)	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Passages Or Figures Appear
	1.	US-5,109,536	28 APR 1992	Komrmusch	
	2.				
	3.				
	4.				
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	10.				
	11.				
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**FOREIGN PATENT DOCUMENTS**

Examiner Initials	Cite No.	Foreign Patent Document Country Code-Number-Kind Code (if known)	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Passages Or Figures Appear	T
	16.					
	17.					
	18.					
	19.					
	20.					
	21.					

Examiner's Signature:

Date Considered: